

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Norio FUKASAWA et al

Serial Number: 09/766,656

Filed: January 23, 2001

For: **METHOD AND MOLD FOR MANUFACTURING  
SEMICONDUCTOR DEVICE, SEMICONDUCTOR  
DEVICE AND METHOD FOR MOUNTING THE DEVICE**



PTO Confirmation No. 1144

Group Art Unit: 2814

Examiners: Graybill, D.

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**INFORMATION DISCLOSURE STATEMENT**  
**PURSUANT TO 37 CFR 1.97(b)**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

June 19, 2003

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO-1449. One copy of each of these documents is attached.

No fee or certification is required in connection with this Information Disclosure Statement, since it is being submitted prior to the issuance of a first official action on the merits or expiration of the three month period following the filing date or the entry of the national stage of the above-captioned application.

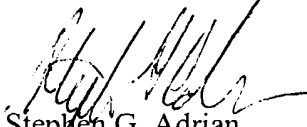
The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. See 37 CFR 1.104(a) concerning the PTO duty to consider and use any such information. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the

documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

The Commissioner is authorized to charge our Deposit Account No. 01-2340 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

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**23850**

PATENT TRADEMARK OFFICE

SGA/lms

Enclosures: 2 European Search Reports  
PTO 1449 w/11 refs.

**INFORMATION  
DISCLOSURE  
CITATION  
PTO-1449**

Atty. Docket No. **980233B**

Serial No. **09/766,656**

Applicant(s): **FUKASAWA et al.**

Filing Date: **January 23, 2001**

Group Art Unit: **2814**

**U.S. PATENT DOCUMENTS**

Examiner Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA	<b>5,431,328</b>	<b>Chang et al.</b>	<b>7-11-95</b>			<b>5-6-94</b>
_____	AB	<b>5,266,528</b>	<b>Yamada</b>	<b>11-30-93</b>			<b>9-9-92</b>
_____	AC	<b>5,408,320</b>	<b>Katagiri et al.</b>	<b>4-18-95</b>			<b>12-22-92</b>
_____	Ad	<b>4,741,787</b>	<b>Shimizu et al.</b>	<b>5-3-88</b>			<b>2-27-86</b>

**FOREIGN PATENT DOCUMENTS**

		Document No.	Date	Country	Translation (Yes or No)
_____	AE	<b>0 689 240 A1</b>	<b>12-27-95</b>	<b>Europe</b>	<b>NA</b>
_____	AF	<b>0 295 914 A2</b>	<b>12-21-88</b>	<b>Europe</b>	<b>NA</b>
_____	AG	<b>54-45570</b>	<b>4-10-79</b>	<b>Japan</b>	<b>Yes-Abstract</b>
_____	AH	<b>6-318609</b>	<b>11-15-94</b>	<b>Japan</b>	<b>Yes-Abstract</b>
_____	AI	<b>WO 96/01495</b>	<b>1-18-96</b>	<b>PCT</b>	<b>NA</b>
_____	AJ	<b>59-225534</b>	<b>12-18-84</b>	<b>Japan</b>	<b>Yes-Abstract</b>
_____	AK	<b>8-72092</b>	<b>3-19-96</b>	<b>Japan</b>	<b>Yes-Abstract</b>

**OTHER DOCUMENTS**

_____	AK	
_____	AL	
Examiner		Date Considered